IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant

: Masahiko NAKAMORI et al.

App. No

10/536,621

Filed

May 26, 2005

For

POLISHING PAD AND METHOD OF

PRODUCING SEMICONDUCTOR

DEVICE

Examiner

Sylvia Macarthur

Art Unit

1792

Conf No.

9275

AMENDMENT

Mail Stop Amendment

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action, dated October 6, 2009, Applicant respectfully submits the following amendments and remarks in connection with the above-captioned application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.